

#17/c PA
w/e
PATENT APPLICATION

RESPONSE UNDER 37 CFR §1.116 11-27-03
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 2825

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Satoshi TAKANO

Group Art Unit: 2825

Application No.: 09/819,690

Examiner: G. Lee

Filed: March 29, 2001

Docket No.: 109107

For: SEMICONDUCTOR MANUFACTURING METHOD, SUBSTRATE PROCESSING
METHOD, AND SEMICONDUCTOR MANUFACTURING APPARATUS

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the June 3, 2003 Office Action, the shortened statutory period for reply
being extended by the attached Petition for Extension of Time, please consider the following:

Amendments to the Claims as reflected in the listing of claims;

Remarks.

OK to Enter
as per
RCE Request of 1/5/04 MMS

~~DO NOT ENTER~~ 1/13/03

OK TO Enter
as per RCE
Request 1/5/04
MMS

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